



Subst. Form PTO-1449		Atty. Docket N .: D/A0488 XER 20399		S rial No.: 09/750,560			
APPLICANT'S(S') INFORMATION DISCLOSURE STATEMENT		Applicant(s): Jaan Noolandi et al.					
		Filing Date: December 28, 2000		Group: 1743			
U.S. PATENT DOCUMENTS							
Initial*		Document No.	Date	Name	Class	Subcl.	Filing Date
JS	AA	4,424,524	1/1984	Daniele	—	—	
	AB	4,509,826	4/1985	Araghi	—	—	
	AC	4,690,391	9/1987	Stoffel et al.	—	—	
	AD	4,712,018	12/1987	Stoffel et al.	—	—	
	AE	4,927,265	5/1990	Brownlee	—	—	
	AF	5,695,626	12/1997	Yeung et al.	—	—	
	AG	5,741,411	4/1998	Yeung et al.	—	—	
JS	AH	5,936,230	8/1999	Street	—	—	
	AI				—	—	
	AJ				—	—	
	AK				—	—	
FOREIGN PATENT DOCUMENTS							
		Document No.	Date	Country	Class	Subcl.	Translation?
	AL						
	AM						
	AN						
	AO						
	AP						
OTHER ART							
JS	AR	Amorphous Silicon Electronics, R.A. Street, Materials Research Society Bulletin, Volume XVII, Number 11, November 1992, pp. 70-76					
	AS	website pages from http://bio.licor.com , (4 pages), (printed 11/13/2000)					
JS	AT	website pages from http://bio.licor.com , (13 pages), (printed 11/17/2000)					
Examiner: <i>Jeffrey S. New</i>				Date Considered: <i>3/10/02</i>			
* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if in conformance and not considered. Include copy of this form with next communication to applicant.							